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| | Filing Date | | 2006-05-03 |
| | First Named Inventor | God et al. | |
| | Art Unit | NA 2876 tkv | |
| | Examiner Name | NA Tuyen kim vo tkv | |
| | Attorney Docket Number | MUHL-1-1004 | |

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| | 2 | 00149486 | | | Lambert et al. | |
| | 3 | 3611883 | | 1971-10-12 | Grob | |
| | 4 | 3763404 | | 1973-10-02 | Aird | |
| | 5 | 6123796 | | 2000-09-26 | Kathmann et al. | |
| | 6 | 5426399 | | 1995-06-20 | Matsubayashi et al. | |
| | 7 | 5681662 | | 1997-10-28 | Chen et al. | |
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| | 4 | DE68921179 | | | 1995-09-21 | ETA S.A. Fabriques | | <input checked="" type="checkbox"/> |
| | 5 | WO01/73686 | | | 2001-10-04 | Plettner | | <input type="checkbox"/> |
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